

03500.017562.



## **PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MAKOTO KUBOTA, et al. )  
Application No.: 10/665,429 )  
Filed: September 22, 2003 )  
For: COMPOSITION FOR FORMING )  
PIEZOELECTRIC FILM, )  
MANUFACTURING METHOD )  
OF PIEZOELECTRIC FILM, )  
PIEZOELECTRIC ELEMENT )  
AND INK JET RECORDING )  
HEAD )  
Examiner: Carol M. Koslow  
Group Art Unit: 1755  
January 23, 2006 (Monday)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT

Sir:

In response to the Office Action dated September 21, 2005, the period for response to which having been extended to Monday, January 23, 2006 by the accompanying Petition for Extension of Time, please amend the above-identified application, as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 23, 2006  
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicant)

Derek Veder (Name of Attorney for Applicant)  
Signature \_\_\_\_\_ Date of Signature January 23, 2006